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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823  
Examiner: George R. Fourson III

In Re PATENT APPLICATION Of:

Applicant(s) : Yasuo TANAKA

Serial No. : 09/660,484

Filed : September 12, 2000

METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE

Attorney Ref. : OKI 262

**RESPONSE TO  
OFFICE ACTION**

December 9, 2004

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office Action dated September 9, 2004.  
For at least the reasons set forth in the Remarks that follow, it is respectfully requested  
that the rejections of the pending claims be reconsidered and withdrawn.

**FEE ENCLOSED:\$**  
**Please charge any further**  
**fee to our Deposit Account**  
**No. 18-0002**